

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Tamotsu NISHI et al.

Group Art Unit: 1797

Appl. No.: 10/598,763

Examiner: Karla Hawkins

I.A. Filed: January 14, 2005

Confirmation No.: 9936

For: APPARATUS FOR REMOVING NITROGEN OXIDES AND METHOD FOR
REMOVING NITROGEN OXIDES

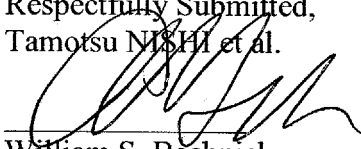
COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Notice of Allowability, mailed by the U.S. Patent and Trademark Office on January 28, 2010, and to the Statement of Reasons for Allowance attached thereto, Applicants wish to clarify the record with respect to the basis for the patentability of claims in the present application. In this regard, while Applicants do not disagree with the Examiner's indication of allowability, Applicants submit that each of the claims in the present application recites a combination of features, and that the basis for patentability of each of these claims is based on the combination of features recited therein.

Respectfully Submitted,
Tamotsu NISHI et al.


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April 8, 2010
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